

Form PTO-1449

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Document Number (Sequence)

TSMC- 01-1457

Application Number

10/672,403

Applicant

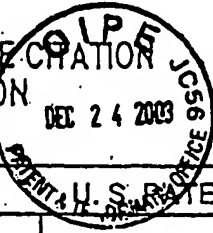
Ta-Chin Lin et al.

Filing Date

09/26/03

Group Art Unit

2125



U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	PLUNG DATE IF APPROPRIATE
CJA	6256548	7/3/01	Lin	700	121	5/8/98
CJA	5841677	11/24/98	Yang et al.	702 <del>364</del>	174 <del>569</del>	5/21/97
CJA	5612886	3/18/97	Weng	700 <del>564</del>	101 <del>468-07</del>	5/12/95
CJR	5950170	9/7/99	Pan et al.	705	7	4/11/97
CJR	5889673	3/30/99	Pan et al.	700 <del>364</del>	97 <del>468-03</del>	12/27/96
CJA	5721686	2/24/98	Shahvaray et al.	700 <del>364</del>	102 <del>468-08</del>	10/31/96
CJR	5546326	8/13/96	Tai et al.	702 <del>364</del>	84 <del>552</del>	4/4/95
CJR	5818716	10/6/98	Chin et al.	700 <del>364</del>	100 <del>468-06</del>	10/18/96
CJR	5751580	5/12/98	Chi	700 <del>364</del>	101 <del>468-07</del>	7/26/96
CJR	5748478	5/5/98	Pan et al.	700 <del>364</del>	99 <del>468-05</del>	3/17/97
CJR	5826238	10/20/98	Chen et al.	705	8	4/2/96

FOREIGN PATENT DOCUMENTS

DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
					YES	NO

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)


EXAMINER

Chen G. P.

DATE CONSIDERED

12/3/04

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.

